



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

March 30, 2026	
IGI Report Number	LG783632162
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OCTAGONAL STEP CUT
Measurements	6.52 X 6.57 X 4.39 MM

GRADING RESULTS

Carat Weight	1.50 CARAT
Color Grade	H
Clarity Grade	VS 1

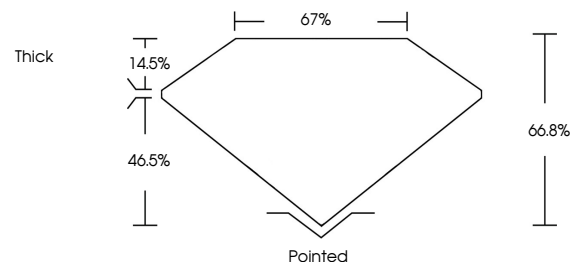
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	151 LG783632162

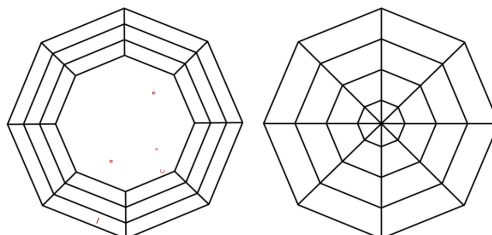
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG783632162
Report verification at igi.org

PROPORTIONS

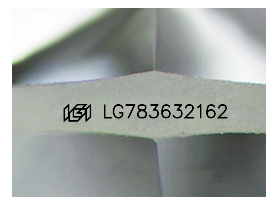


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

LABORATORY GROWN DIAMOND REPORT



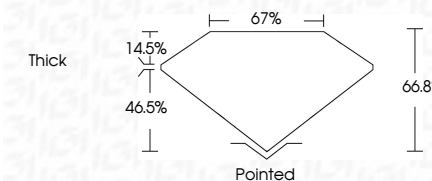
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March 30, 2026
GI Report No LG783632162
OCTAGONAL STEP CUT

1.50 CARAT	VS 1	66.8%	67%	Thick	Pointed	EXCELLENT	EXCELLENT	NONE	None
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(CVD) growth process.

www.igi.org